

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Inventors: Jaime Poris
Assignee: Nanometrics Incorporated
Title: Accurate Thickness Measurement of Thin Conductive Film
Serial No.: Unknown Filing Date: July 11, 2003
Examiner: Unknown Group Art Unit: Unknown
Docket No.: NAN068 US Confirmation No: Unknown

Santa Clara, California
July 11, 2003

MAIL STOP PATENT APPLICATION
COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA VA 22313-1450

**INFORMATION DISCLOSURE STATEMENT
UNDER 37 CFR §1.97(b)**

Dear Sir:

Pursuant to 37 C.F.R. § 1.56, §1.97 and §1.98, the Applicants submit for consideration in the above-identified patent application the document listed on the accompanying Form PTO-1449. A copy of the document is also submitted herewith. The Examiner is requested to make this document of record.

This Information Disclosure Statement is submitted pursuant to 37 CFR §1.97(b) as it within three months of the filing date of a national application other than a continued prosecution application and/or before the mailing of a first Office Action on the merits. Accordingly, no fee is required.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

In addition, Applicants submit for the Examiner's consideration the following co-pending and co-owned application, cited by serial number, first named inventor and filing date.

	Serial No.:	First Named Inventor	Date:
1.	10/402,661	Jaime Poris	March 28, 2003

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The Applicants presume that the Examiner has access to and will review the co-pending applications and the files thereof for any office actions, amendments or other materials that may be relevant to the patentability of the claims of the present application. For any such U.S. patent application(s) that are currently pending, the Applicants further presume that the Examiner will consider any future office actions, amendments or other materials in the file thereof that may be relevant to the patentability of the claims herein. **If the Applicants' understanding in this regard is not correct, please notify the undersigned so that copies of any such documents can be submitted to the Examiner with the necessary precautions so that the file may be expunged of any proprietary information that is considered unimportant to a reasonable examiner.**

The co-pending application in the above list is unpublished. Applicants do not believe that it is proper for the listed application to appear on the face of any patent that may issue from the present application, and accordingly, Applicants have not listed these applications on a PTO-Form 1449.

The information contained in this Information Disclosure Statement under 37 C.F.R. §1.555 is to the best of my knowledge and is not to be construed as a representation that: (i) a complete search has been made; (ii) additional information material to the examination of this application does not exist; (iii) the information, protocols, results and the like reported by third parties are accurate or enabling; or (iv) the above information constitutes prior art to the subject invention.

Via Express Mail Label No.
ER 308 113 655 US

Respectfully submitted,



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U.S. Department of Commerce, Patent and Trademark Office INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use several sheets if necessary)				Application No.:	Unknown		
				Filing Date:	July 11, 2003		
				First Named Inventor:	Jaime Poris		
				Group Art Unit:	Unknown		
				Examiner Name:	Unknown		
				Confirmation No.:	Unknown		
				Attorney Docket No.:	NAN068 US		
U.S. Patent Documents							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	1.	4,849,694	Jul. 18, 1989	Coates	324	230	
	2.	5,525,903	Jun. 11, 1996	Mandl et al.	324	230	
	3.	5,625,170	Apr. 29, 1997	Poris	177	50	
	4.	US 2002/0053904	May 9, 2002	Chen et al.	324	230	
	5.	US 6,407,546 B1	Jun. 18, 2002	Le et al.	324	230	
	6.	US 6,433,541 B1	Aug. 13, 2002	Lehman et al.	324	230	
	7.	US 6,563,308 B1	May 13, 2003	Nagano et al.	324	230	
	8.	US RE37,749 E	Jun 18, 2002	Poris	204	230.1	
OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)							
	9.	“Eddy Current Theory – Testing”, http://www.hocking.com/theory_testing.htm , downloaded March 6, 2003, 9 pages					
Examiner			Date Considered				
<p>*EXAMINER: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.</p>							